Inventor: Sang Woo NAM For: "Methods for Forming Capacitors and Contact Holes Having Semiconductor Devices Simultaneously" Attorney Docket No. 20063/10006 Sheet 1 of 4

Fig. 1a

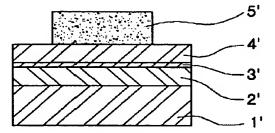
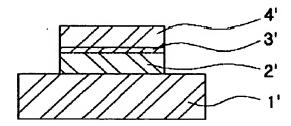
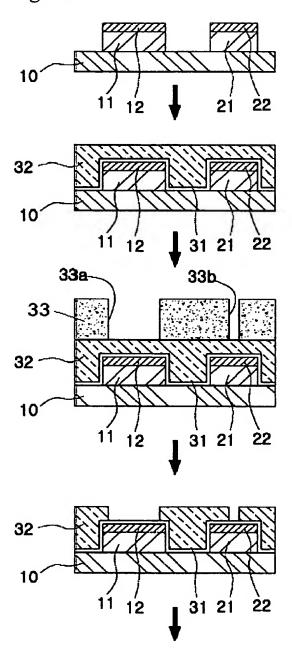


Fig. 1b



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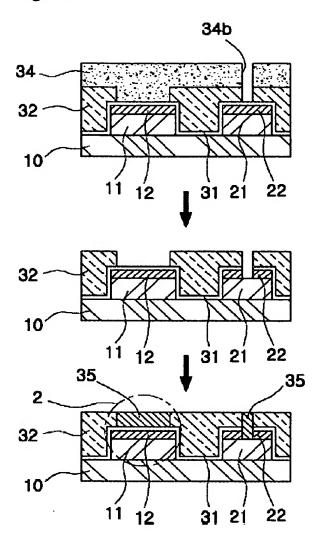
Fig. 2a



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Fig. 2b



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Fig. 3

